



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 29, 2024

IGI Report Number
Description
Shape and Cutting Style
Measurements

LG641468951
LABORATORY GROWN DIAMOND
CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT
8.29 X 5.74 X 3.86 MM

GRADING RESULTS

Carat Weight
Color Grade
Clarity Grade

1.61 CARAT
E
INTERNALLY FLAWLESS

ADDITIONAL GRADING INFORMATION

Polish
Symmetry
Fluorescence

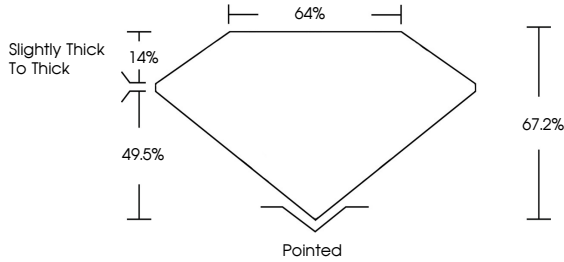
EXCELLENT
EXCELLENT
NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG641468951

PROPORTIONS





Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³
Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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June 29, 2024
IGI Report No LG641468951
CUT CORNERED RECT. MODIFIED BRILLIANT
8.29 X 5.74 X 3.86 MM
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Culet
Polish
Symmetry
Fluorescence
Inscription(s)

1.61 CARAT
E
IF
67.2%
64%
Slightly Thick To Thick
Pointed
EXCELLENT
EXCELLENT
NONE
 LG641468951

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